

## Amendments to the Claims

This the claims will replace all prior versions and listings of claims in the application.

## **Listing of Claims:**

1. (currently amended): An organic electro-luminescent display device, comprising: a glass substrate;

an optic-compensation film of transparent dielectric material formed on the surface of the glass substrate;

an anode layer formed <u>directly</u> on the optic-compensation film; a laminated body of organic material formed on the anode layer; and a cathode layer formed on the laminated body.

- 2. (original): The organic electro-luminescent display device as claimed in claim 1, wherein the optic-compensation film is silicon nitride (SiNx).
- 3. (original): The organic electro-luminescent display device as claimed in claim 1, wherein the optic-compensation film is of 100~3000Å thickness.
- 4. (original): The organic electro-luminescent display device as claimed in claim 1, wherein the optic-compensation film promotes transparency of red light to approximately 90%.
- 5. (original): The organic electro-luminescent display device as claimed in claim 1, wherein the anode layer is ITO.
- 6. (original): The organic electro-luminescent display device as claimed in claim 1, wherein the laminated body comprises:
  - a hole-injecting layer formed on the anode layer; an organic luminescent material layer formed on the hole-injecting layer; and

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an electron-injecting layer formed on the organic luminescent material layer.

7. (original): The organic electro-luminescent display device as claimed in claim 1, wherein the organic electro-luminescent display device is an OLED device or a PLED device.

8. (currently amended): A method of forming an organic electro-luminescent display device, comprising:

providing a glass substrate;

forming an optic-compensation film of transparent dielectric material on the surface of the glass substrate, in which the transparent nature of the optic-compensation film is not limited to light of a specific wavelength;

forming an anode layer <u>directly</u> on the optic-compensation film; forming a laminated body of organic material on the anode layer; and forming a cathode layer on the laminated body.

- 9. (original): The method of forming an organic electro-luminescent display device as claimed in claim 8, wherein the optic-compensation film is silicon nitride (SiNx).
- 10. (original): The method of forming an organic electro-luminescent display device as claimed in claim 8, wherein the optic-compensation film is of 100~3000Å thickness.
- 11. (original): The method of forming an organic electro-luminescent display device as claimed in claim 8, wherein the optic-compensation film promotes transparency of red light to approximately 90%.
- 12. (original): The method of forming an organic electro-luminescent display device as claimed in claim 8, wherein the optic-compensation film increases the transparency of red light.

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13. (original): The method of forming an organic electro-luminescent display device as claimed in claim 8, wherein the anode layer is ITO.

14. (original): The method of forming an organic electro-luminescent display device as claimed in claim 8, wherein the laminated body comprises:

a hole-injecting layer formed on the anode layer; an organic luminescent material layer formed on the hole-injecting layer; and an electron-injecting layer formed on the organic luminescent material layer.

15. (original): The method of forming an organic electro-luminescent display device as claimed in claim 8, wherein the organic electro-luminescent display device is an OLED device or a PLED device.